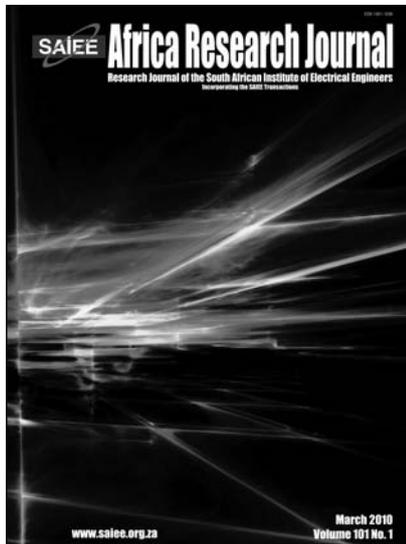


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**GBi** electric  
low voltage

 Eskom